

## Hard X-ray self-seeding for XFELs: towards coherent FEL pulses

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G. Geloni, V. Kocharyan, E. Saldin, 2011 Free Electron Laser Conference, Shanghai, August 23th 2011



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# Self-seeding techniques and their importance for XFELs

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## Self-seeding techniques and their importance for XFELs

SASE pulses, baseline mode of operation: poor longitudinal coherence



European

**Figure 5.2.4** Temporal (top) and spectral (bottom) structure for 12.4 keV XFEL radiation from SASE 1. Smooth lines indicate averaged profiles. Right side plots show enlarged view of the left plots. The magnetic undulator length is 130 m.

#### Source: The European XFEL TDR - DESY 2006-097 (2006)

$$\frac{\Delta\omega}{\omega} \sim 2\rho \sim 10^{-3}$$
$$\left(\frac{\Delta\omega}{\omega}\right)_{spike} \sim \frac{1}{\sigma_T \omega} \sim 10^{-5}$$

- Hundreds of longitudinal modes
- A lot of room for improvement

1 a

Self-seeding schemes answer the call for increasing longitudinal coherence

## Single-bunch self-seeding with a fourcrystal monochromator



European

- Method historically introduced for soft x-rays in:J. Feldhaus et al., Optics Comm. 140, 341 (1997)
  - Linearly amplified SASE is filtered through a grating monochromator
  - Electron beam bypass washes-out beam microbunch, makes up for x-ray path delay by grating and allows for grating installation
  - Demodulated beam is seeded in the output undulator

Grating monochromator substituted by crystal monochromator for applications to hard-x rays:
 [E. Saldin, E. Schneidmiller, Yu. Shvyd'ko and M. Yurkov, NIM A 475 357 (2001)]

Extra x-rays path due to monochromator ~1cm. Long electron bypass (tens of meters) needed



## Double-bunch self-seeding with a fourcrystal monochromator



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## Self-seeding techniques with a singlecrystal monochromator: -Working principle-





First part: usual SASE  $\rightarrow$  linear regime pulse

Weak chicane ( $R_{56}$  ~ several  $\mu$ m for short pulse mode of operation) for:

- Creating a small offset (a few mm) to insert the monochromator
- Washing out the electron beam microbunching
- Acting as a tunable delay line
- The photon pulse from SASE goes through the monochromator
- Photon and electron pulses are recombined

## Working principle (II)



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KK realtion link modulus and phase. In fact  

$$|T(\eta)| = 2\sqrt{|\eta^2 - 1|}$$

$$\times \left| \left( \eta + \sqrt{\eta^2 - 1} \right) \exp \left[ \frac{i\pi t_c}{\Lambda_B} \sqrt{\eta^2 - 1} \right] - \left( \eta - \sqrt{\eta^2 - 1} \right) \exp \left[ -\frac{i\pi t_c}{\Lambda_B} \sqrt{\eta^2 - 1} \right] \right|^{-1}$$

Has no zeros on the upper complex plane (so that ln[|T|] is not singular and we can recover the phase).



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#### **Working principle - Intermezzo**



## Working principle (III)

The single-crystal monochromator principle: frequency vs. time



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## Self-seeding techniques with a single-crystal monochromator: Feasibility study for the LCLS -short bunch mode of operation-

## European XFEL Feasibility study for LCLS (I)



## Feasibility study for LCLS (II)



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### Feasibility study for LCLS (IV)



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## Self-seeding techniques with a singlecrystal monochromator: Feasibility study for the European XFEL -short bunch mode of operation-

## Feasibility study for the European XFEL



| Parameters for the short pulse mode of operation |         |       |  |  |  |  |  |
|--|---------|-------|--|--|--|--|--|
|  | Units   |       |  |  |  |  |  |
| Undulator period                                 | mm      | 48    |  |  |  |  |  |
| K parameter (rms)                                | -       | 2.516 |  |  |  |  |  |
| Wavelength                                       | nm      | 0.15  |  |  |  |  |  |
| Energy   | GeV     | 17.5  |  |  |  |  |  |
| Charge   | nC      | 0.025 |  |  |  |  |  |
| Bunch length (rms)                               | $\mu$ m | 1.0   |  |  |  |  |  |
| Normalized emittance                             | mm mrad | 0.4   |  |  |  |  |  |
| Energy spread                                    | MeV     | 1.5   |  |  |  |  |  |

European

5m-long magnetic chicane
 R<sub>56</sub>=12μm



## European XFEL pulse repetition rate ~ 27000 Hz $\rightarrow$ compromise in the first undulator length (heat loading!)





Average incident power density at normal incidence within a train: 300 W/mm<sup>2</sup> (25pC) – 3000 W/mm<sup>2</sup> (0.25nC)





About 30000 bunches/s vs. 10 bunches/s
 → Heat loading much more severe for European XFEL
 → Cannot increase length of first undulator part
 → Relevant SASE contribution

#### Feasibility study for the European XFEL (.....)

Three-undulator setup



Small SASE contribution: at the second filter BW nearly Fourier limited already



#### Tapering scheme



## Similarly as for LCLS to increase output power/brightness

#### Feasibility study for the European XFEL (...)



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## Self-seeding techniques with a singlecrystal monochromator

## Nominal mode of operation - LCLS - Inclusion of S2E simulations -

## Feasibility study for the LCLS Inclusion of S2E simulations (I)



|                      | Units   |       |
|----------------------|---------|-------|
| Undulator period     | mm      | 30    |
| K parameter (rms)    | -       | 2.466 |
| Wavelength           | nm      | 1.55  |
| Energy               | GeV     | 13.4  |
| Charge               | nC      | 0.25  |
| Bunch length (fw)    | $\mu m$ | 26.6  |
| Normalized emittance | mm mrad | 0.4   |
| Energy spread        | MeV     | 1.4   |

## Feasibility study for the LCLS Inclusion of S2E simulations (II)

#### **Results from S2E simulations as GENESIS input**



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## Feasibility study for the LCLS Inclusion of S2E simulations (III)



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## Self-seeding techniques with a singlecrystal monochromator

- Doublet/multiplet generation -

## **Doublet generation scheme**



operation of wake monochromator at two closely spaced wavelengths

European

| X-rays at 0.15 nm<br>bandwidth 0.2 % | Bragg geometry<br>C ( 400 ) reflection<br>of 0.15005 nm X-rays<br>diamond crystal plate<br>0.1 mm thick<br>n<br>diamond crystal plate<br>0.1 mm thick<br>diamond crystal plate<br>0.1 mm thick<br>diamond crystal plate<br>0.1 mm thick<br>diamond crystal plate<br>0.1 mm thick<br>diamond crystal plate<br>0.1 mm thick<br>Bragg geometry<br>C ( 400 ) reflection<br>of 0.15016 nm X-rays |                      | Units   |                      |         |       |
|--------------------------------------|---|----------------------|---|----------------------|---------|-------|
|                                      |   |                      | in a series<br>forward-diffracted X-rays<br>diamond crystal plate<br>0.1 mm thick | Undulator period     | mm      | 30    |
|                                      |   | arranged in a series |   | K parameter (rms)    | -       | 2.466 |
|                                      |   | f                    |   | Wavelength           | nm      | 0.15  |
|                                      |   | diamond cryst        |   | Energy               | GeV     | 13.6  |
|                                      |   | 0.1 mm thick         |   | Charge               | nC      | 0.02  |
|                                      |   | 0) reflection B      | Bunch length (rms)  | $\mu { m m}$         | 1       |       |
|                                      |   | of 0.15016 nm        | of 0.15016 nm X-rays  | Normalized emittance | mm mrad | 0.4   |
|                                      |   |                      |   | Energy spread        | MeV     | 1.5   |

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### **Doublet generation: crystal effect**



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The doublet setup can be used for COTR production. It can exploit the electron beam modulation naturally induced at optical wavelength



NA=0.1  $\rightarrow$  1e11 ph/pulse



## Self-seeding techniques with a singlecrystal monochromator

Extension for soft X-rays

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## Extensions to soft X-rays – comparison (,)

## The physical principle behind the self-seeding scheme can be exported to different setups



#### Hard X-rays

European

Soft X-rays

## <u>Conceptually</u> we are playing the same game! <u>Practically</u> we will need to implement some changes in the setup

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$$I(\omega) = I_0 exp[-n_0 l\sigma(\omega)] \longrightarrow |T| = exp[-n_0 l\sigma/2]$$

$$\ln[T(\omega)] = \ln[|T(\omega)|] + i\Phi(\omega) = -nl\sigma/2 + i\Phi(\omega)$$





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- 1. Not all resonances can be used
- The wavelength is too long (~20 nm) → Practical changes
   →Harmonics



LCLS-II baseline tunable gap undulator with 60mm period, K = 1.3-12 Beta function 10m Cell length 3.7m Undulator segment length = 3m

## Extensions to soft X-rays – feasibility (I.,



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## Extensions to soft X-rays – feasibility (III)



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## Conclusions

- Solves the problem of poor longitudinal coherence for hard x-ray FELs
  - Bandwidth down to 10<sup>-4</sup> for Q=0.02 nC (depends on mode of operation)

#### Robust

- Baseline mode of operation is easily recovered
- Minimal modifications to the baseline setup
  - No need for long electron bypass
  - No need for special photo-injector setup
  - Only needs: 1 weak chicane + 1 crystal (or gas cell) within a single segment
- Low cost



# Thank You!

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